



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)	
Christoph Moelle et al.)	Group: 2872
Serial No.: 10/637,203)	
Filed: August 8, 2003)	Examiner: M.Y. Sikder
Title: OBJECT WHICH HAS OPTICAL LAYERS)	

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant wishes to bring to the attention of the Examiner the document identified on the attached form PTO-1449. Applicants respectfully request that this document be made of record in the present application.

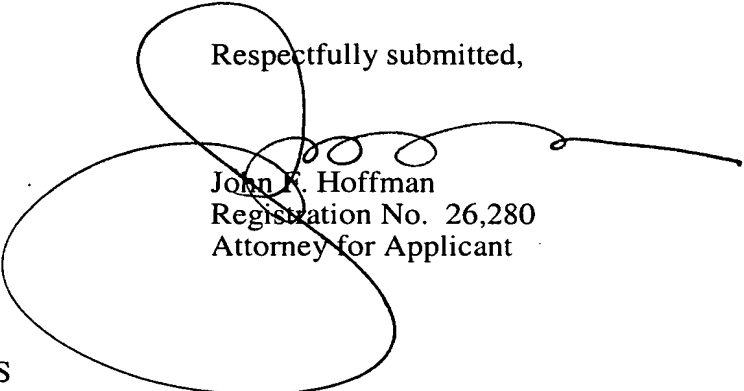
WO 96/27690 is mentioned in the previously cited United States published application US 2003/0021909. WO 96/27690 describes a PECVD ("plasma enhanced chemical vapor deposition") method and a device for the two-sided coating of substrates, preferably spectacle lenses, by means of microwave excitation. A distinct plasma is used for each surface to be coated. In order to keep the heat load of the substrate low, the use of a pulsed discharge is recommended. No mention is made of which uniformities can be obtained in the coating and how they can be influenced.

Applicants' German representative has advised that this means that the process is a plasma impulse chemical vapor deposition process.

PATENT

If any fees are necessary in connection with this document, or insufficient fees are sent herewith, please charge Deposit Account No. 02-0385, Baker & Daniels.

Respectfully submitted,



John F. Hoffman
Registration No. 26,280
Attorney for Applicant

JFH/pmp

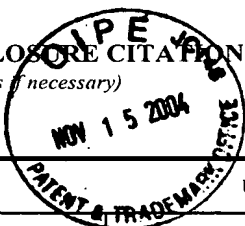
BAKER & DANIELS
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111 East Wayne Street
Fort Wayne, IN 46802
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Facsimile: 260-460-1700

Enc. Form PTO-1449
Cited Reference

Date: November 10, 2004

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

WEI0024-02

Application Number

10/637,203

Applicant(s)

Christoph Moelle et al.

Filing Date

August 8, 2003

Group Art Unit

2872

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		WO 96/27690	09/1996	PCT (*)			✓	

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

(*) = English language abstract only

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.